

Notice of References Cited	Application/Control No. 09/741,857	Applicant(s)/Patent Under Reexamination MODELSKI ET AL.	
	Examiner Chad Zhong	Art Unit 2152	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2005/0086353	04-2005	Shirakawa et al.	709/230
	B	US-6,625,150	09-2003	Yu, JungJi John	370/389
	C	US-2004/0083299	04-2004	Dietz et al.	709/230
	D	US-2003/0037228	02-2003	Kelsey et al.	712/245
	E	US-6,662,252	12-2003	Marshall et al.	710/200
	F	US-2005/0190694	09-2005	Ben-Nun et al.	370/229
	G	US-5,907,702	05-1999	Flynn et al.	718/108
	H	US-6,012,138	01-2000	Worrell, Frank	712/209
	I	US-2005/0243850	11-2005	Bass et al.	370/412
	J	US-2001/0037444	11-2001	MUNSON et al.	712/207
	K	US-6,813,243	11-2004	Epps et al.	370/235
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"The RISC Concept - A survey of Implementations", Esponda et al., September 1991
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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